

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Taisuke HIRONO ET AL.

Serial No.:

09/901,288

Filing Date:

07/09/2001

For:

CUVETTE CONTROL UNIT AND CONTROLLING

METHOD USING THE SAME.

CERTIFICATE UNDER 37 CFR 1.8(a) I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING DEPOSITED WITH THE UNITED STATES POSTAL SERVICE AS FIRST CLASS MAIL IN AN ENVELOPE ADDRESSED TO ASSISTANT COMMISSIONER FOR PATENTS, WASHINGTON, D.C. 20231.

REG NO

DATE August 6, voi

TRANSMITTAL LETTER

Asst. Commissioner for Patents Washington, D.C. 20231

Sir:

Please find enclosed for filing:

✓ Claim of Foreign Priority; and

Certified Copy of Japanese Patent Application No. 2000-209021.

Should any fees or surcharges be incurred please debit Deposit Account No. 04-1679.

This Transmittal Letter is submitted in duplicate.

✓ Return Postcard.

Respectfully submitted,

Date: Wyulb

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Docket No. 3005-29